Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	CASE NO. 4658	SERIAL NO. 09/583,512
INFORMATION DISCLOSURE STATEMENT *(Use several sheets if necessary)*		APPLICANT Wu et al.	
		FILING DATE May 31, 2000	GROUP Not yet assigned

OIPE JUN 21 2000 PATENT & TRADEMARK OFFICE

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	TRANSLATION NO
GR		99/22908	05/14/99	PCT	B24B	37/04		
GR		98/45090	10/15/98	PCT	B24B	53/10		

OTHER *(Including Author, Title, Date, Pertinent Pages, Etc.)*

GR		Birang et al. "Apparatus and Method for Chemical Mechanical Polishing with an Advanceable Polishing Sheet" U.S. Patent Application No. 09/244,456 filed February 4, 1999

EXAMINER	DATE CONSIDERED
	06/25/01

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.